



1 Inventor: Kevin J. Torek et al.

2 Title: Methods of Removing at Least Some of a Material from a
Semiconductor Substrate

Assignee: Micron Technology, Inc.

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8 INFORMATION DISCLOSURE STATEMENT

9 PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

10 In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's
11 attention is directed to the references listed on the attached Form PTO-1449
12 and copies of which are attached. No admission is made regarding whether
13 all the submitted references are prior art.

14 Citation of these references is respectfully requested.

15 Respectfully submitted,

16
17 Date: 12/8/00

Attorney: [Signature]

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